



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takashi IGARASHI et al.

Group Art Unit: 3723

Application No.: 10/611,918

Examiner:

H. SHAKER

Filed: July 3, 2003

Docket No.:

108833.01

For:

LENS MACHINING APPARATUS, LENS MACHINING METHOD, AND LENS

MEASUREMENT METHOD

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the March 27, 2007 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.